

Form PTO-1449 U.S. Department of Commerce (Rev. 8-83) Patent and Trademark Office			Atty. Docket No.: 0756-1921	Serial No. 09/226,216
INFORMATION DISCLOSURE STATEMENT <small>(Use several sheets if necessary)</small>		Applicant: Hisashi OHTANI, et al.		
		Filing Date: January 7, 1999	Group: 2811	

U.S. PATENT DOCUMENTS

Examiner Initial		Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date (if approp.)
<i>John</i>		5,424,244	06/13/95	Zhang et al.	—	—	
<i>John</i>		5,700,333	12/23/97	Yamazaki et al.	—	—	
<i>John</i>		5,830,784	11/03/98	Zhang et al.	—	—	
<i>John</i>		5,859,443	01/12/99	Yamazaki et al.	—	—	
<i>John</i>		5,897,347	04/27/99	Yamazaki et al.	—	—	
<i>John</i>		5,915,174	06/22/99	Yamazaki et al.	—	—	
<i>John</i>		5,932,892	08/03/99	Hseuh et al.	—	—	
<i>John</i>		5,932,893	08/03/99	Miyanaga et al.	—	—	
<i>John</i>		5,953,597	09/14/99	Kusumoto et al.	—	—	
<i>John</i>		5,961,743	10/05/99	Yamazaki et al.	—	—	
<i>John</i>		5,962,871	10/05/99	Zhang et al.	—	—	
<i>John</i>		5,977,559	11/02/99	Zhang et al.	—	—	

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Relevant Pages, Date, Place of Publication)

[Signature] James W. Mayer, "ELECTRONIC MATERIAL SCIENCE: FOR INTERGRATED CIRCUITS IN Si AND GaAs," Macmillan Publishing Company, New York, 1990, pp. 176-179.

Examiner hans Schillinger Date Considered 8/23/00